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Dated: January 12, 2005

Signature: \_\_\_\_\_

(Michael R. Hull)

Docket No.: 29926/39505  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Young-Soo Kim

Application No.: 10/615,038

Confirmation No.: 3909

Filed: July 8, 2003

Art Unit: 2824

For: ATOMIC LAYER DEPOSITION OF  
TITANIUM NITRIDE USING BATCH TYPE  
CHAMBER AND METHOD FOR  
FABRICATING CAPACITOR BY USING THE  
SAME

Examiner: Bradley Smith

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

This paper is filed in response to the office action mailed on September 29, 2004. Please amend the above-identified patent application as follows.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.